THIN FILMS DEPOSITED BY SPIN COATING TECHNIQUE: REVIEW

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Abstract:

Nanostructure thin films have been prepared and deposited onto various substrates such as glass substrate, quartz, GaN (0001) substrate, indium tin oxide coated glass, soda-lime glass, microscope glass slide via spin coating technique. This deposition method has many advantages, such as being cheap, simple, suitable for the low-temperature deposition process. Literature review revealed that the deposition process was carried out at different conditions produced unique properties of films. Structural, morphological, and optical properties were studied by X-ray diffraction, scanning electron microscopy, atomic force microscopy, and UV-Visible spectrophotometer. It was found that the average grain size of the obtained films was in the nanometer scale. The research findings confirmed that these materials could be used for photovoltaic applications.

Keywords: spin coating technique, substrate, thin films, photovoltaic applications

1. INTRODUCTION

The thin film's development for energy conversion and optoelectronic materials, among other applications, is of great interest [1,2]. Because of the low cost, non-toxic starting materials indicate excellent electrical, photovoltaic, photocatalytically and optical properties [3-6]. Nowadays, there is an extended interest in researching different synthesis methodologies for metal chalcogenide thin films, such as metal selenide, metal sulfide, and metal telluride thin films. Several synthesis methodologies for these materials have been reported including spray pyrolysis [7,8], electrodeposition [9,10], thermal evaporation [11,12], chemical bath deposition [13,14], successive ionic layer adsorption and reaction [15,16], atomic layer deposition [17], molecular beam epitaxy [18], pulsed laser deposition [19], and sol-gel method [20]. Researchers conclude that each methodology has advantages and disadvantages [21-24]. Among the main disadvantages are high cost, toxicity, elevated synthesis temperatures, a considerable number of by-products, annealing requirements at high temperatures after synthesis that limit the use of flexible substrates, and films heterogeneity. Several instruments including atomic force microscopy (AFM), Rutherford backscattering spectrometry (RBS), X-ray diffraction (XRD), scanning electron microscopy (SEM), energy dispersive X-ray analysis (EDAX), scanning tunneling microscopy [25,26], Raman spectrometry, real-time reflection high energy electron diffraction [27,28], UV-Visible spectrophotometer (UV-Visible) are used to investigate general properties of films.

This work presented a review of the preparation of thin films using a spin coating technique. This method was chosen for simplicity, low cost, low by-product formation, low temperature, and no-annealing requirements. Structural, electrical, optical, and morphological properties of the prepared thin films were discussed.

The deposition technique could be divided into chemical deposition technique and physical deposition method. Generally, a higher operational cost is needed to synthesize thin films using the physical method (Figure 1). Thin films have been prepared by using various deposition methods, as highlighted by many researchers. Metal selenide, metal sulphide, and metal telluride thin films were reported as listed in Table (1- 3). Characterization of obtained films was carried out by using various tools.

Fig. 1: Thin film deposition methods [29]**Table 1:** Metal selenide thin films have been prepared under various deposition methods

Thin films	Deposition method	Experimental results
ZnSe	Chemical bath deposition	<ul style="list-style-type: none"> • AFM: uniform grain size and complete coverage over the substrate for the films prepared at pH 2 [30].
CdSe	Chemical bath deposition	<ul style="list-style-type: none"> • RBS = excess of cadmium rather than selenium [31]. • UV-Visible: bandgap (3.52 to 1.86 eV). • XRD: cubic structure. • SEM: diameter of 33nm and 40 nm for the films prepared at 40 and 50 °C.
NiSe	Chemical bath deposition	<ul style="list-style-type: none"> • XRD: rhombohedral structural. • AFM: covered the surface of the substrate and irregularly shaped grains [32]. • UV-Visible: bandgap (1.8 eV).
PbSe	Chemical bath deposition	<ul style="list-style-type: none"> • XRD: cubic with the most preferential peak corresponded to (111) plane. • UV-Visible: Bandgap reduced from 2 to 1.3 eV as bath temperature was increased [33].
ZnSe	Thermal evaporation	<ul style="list-style-type: none"> • XRD: cubic phase and the highest peak corresponded to (111) plane [34]. • AFM: Smooth surface and roughness (6.7 nm). • UV-Visible: Bandgap of 2.7 eV and high transmission (89%) in the infrared region.

Table 2: Metal sulphide thin films have been prepared under various deposition methods

Thin films	Deposition method	Experimental results
CuS	Chemical bath deposition	<ul style="list-style-type: none"> • AFM: incomplete coverage of the materials over the surface of a substrate for the films prepared at one hour [35].
Cu ₄ SnS ₄	Electro deposition	<ul style="list-style-type: none"> • XRD: orthorhombic structure [36]. • AFM: small grain and uniform surface for the films prepared at 25 °C for 45 minutes. • UV-Visible: 1.68 eV.
Ni ₃ Pb ₂ S ₂	Chemical bath deposition	<ul style="list-style-type: none"> • SEM: homogeneous and regular surface for the films prepared at 1 hour [37].
SnS	Chemical bath deposition	<ul style="list-style-type: none"> • XRD: The strongest peak at $2\theta=31.69^\circ$. • SEM: non-uniform surface and grain sizes (10-25 nm) [38].
Ni ₄ S ₃	Chemical bath deposition	<ul style="list-style-type: none"> • XRD: cubic structure. • UV-Visible: 0.85 to 1.8 eV depending on the pH [39].
CdS, CuS, ZnS	SILAR	<ul style="list-style-type: none"> • XRD: CdS (hexagonal), CuS (covellite), ZnS (cubic). • SEM: homogeneous and covered the substrate well [40].

FeS ₂	Chemical bath deposition	<ul style="list-style-type: none"> • XRD: strong peak corresponded to (110) plane [41]. • SEM: Irregular grains. • UV-Visible: band gap of 1.85 eV.
PbS	SILAR	<ul style="list-style-type: none"> • XRD: prominent peak was corresponded to (200) plane [42]. • AFM: film thickness (20-30 nm).
ZnS	RF magnetron sputtering	<ul style="list-style-type: none"> • SEM: grain size (69 nm). • UV-Visible: bandgap of 3.79 eV. • XRD: show (111) plane and indicate zinc blende structure [43].
PbS	Chemical bath deposition	<ul style="list-style-type: none"> • SEM: non-uniform and dense [44]. • EDAX: atomic percentage of Pb:S was 49.18:50.82%.
ZnS	Thermal evaporation	<ul style="list-style-type: none"> • XRD: cubic zinc blend structure with (111) preferential plane [45]. • UV-Visible: bandgap of 3.5 eV. • SEM: the films are pinhole-free.
FeS	Chemical bath deposition	<ul style="list-style-type: none"> • XRD: Thin films prepared using 0.1M, 0.15 M and 0.2 M of solution concentration indicated 3, 4, and 5 peaks, respectively [46]. • SEM: the films prepared using 0.2 M covered the entire surface of the substrate.

Table 3: Metal telluride thin films have been prepared under various deposition methods

Thin films	Deposition method	Experimental results
ZnTe	SILAR	<ul style="list-style-type: none"> • EDAX: Zn:Te was 53:47. • SEM: densely aggregated particles (in nm) without voids [47].
CdTe	RF magnetron sputtering	<ul style="list-style-type: none"> • XRD: strong (111) orientation and cubic structure [48]. • UV-Visible: band gap values (1.44 to 1.6 eV).
Bi ₂ Te ₃	Thermal co-evaporation	<ul style="list-style-type: none"> • XRD: strong (105) orientation and rhombohedral structure [49].
SnTe	Molecular beam epitaxy	<ul style="list-style-type: none"> • STM: tetragonal structure. • RHEED: formation of flat films [50].
CdTe	Electrodeposition	<ul style="list-style-type: none"> • XRD: prominent peak was observed at (111) plane [51]. • Raman: Peak at 140 cm⁻¹ indicated CdTe fingerprint.

Spin coating is employed in a wide variety of industries, semiconductor and nanotechnology sectors. It offers several advantages, including easy to set-up, require low temperature for deposition process [52], it does not limit the choice of the substrate material [53], low-cost, simple form uniform and homogeneous [54] thin films (in nanoscale thickness) [55] onto the flat substrate and produce well-defined coating coverage. It employs centrifugal forces created by a spinning substrate to spread a coating solution evenly over the substrate. During the deposition process, solid particles are dissolved in a solvent. The mixture is spin-coated on the surface of the substrate. The process produces a gelatinous network on the substrate. Subsequent solvent removal solidifies the gel [56], resulting in solid film [57]. Film thickness will depend on the nature of coating [58] and the conditions [59] chosen for the spin process, such as rotation speed

[60], viscosity, and concentration of the solution. The solvent evaporates during the spin coating process and causes an increasing concentration and viscosity [61]. The more concentrated the solution, the thicker films could be produced. The stages of the deposition of the thin films by the spin coating method are shown in Figure (2) reported by Marek and Dobrzanski [62].

Fig. 2: The stages of the deposition of thin films by a spin coating method

The $\text{Cu}_2\text{Zn}_{0.8}\text{Cd}_{0.2}\text{SnS}_4$ films were synthesized using the spin coating method onto glass substrate [63]. The solution of copper (II) chloride monohydrate, zinc (II) acetate dihydrate, tin (II) chloride dihydrate, cadmium (II) chloride, thiourea, monoethanolamine, and 2-methoxyethanol was used during the deposition process. XRD patterns confirm that the presence of ZnS, SnS, Cu_2S , and CZTS in obtained samples. Larger grain sizes (35 to 68 nm) and the intensity of peaks become more intense, with increasing copper concentration from 0.3 to 0.9 M. In other words, they found that bigger grain size brings an advantage in improving photovoltaic performance. EDAX spectra reveal that the films were copper-rich and tin-rich, while SEM studies indicate the spherical grains with voids for the films prepared at high concentrations of copper solution (0.7 and 0.9 M). Optical properties reveal that all the samples have an absorption coefficient of more than 10^4 cm^{-1} , and the bandgap value reduces (1.8 to 1.6 eV) with an increase in copper concentration.

$\text{Cu}_2\text{CdSnS}_4$ (CCTS) thin films have been prepared on GaN (0001) substrate using spin-coating technique under different spin coating speeds [64]. The optical properties indicate the changing of bandgap as the spin coating speed increases from 1500 (2.7 eV), 2000 (2.55 eV), 2500 (2.4 eV), 3000 (2.5 eV) to 3500 (2.6 eV) rpm. Structural properties displayed that nine and ten peaks could be observed for the films prepared at 1500 and 3500 rpm, respectively and confirmed tetragonal stannite structure. However, these peaks have less intensity if compared to other speeds. It is worth noting that the morphology was the best at 3500 rpm, enhancing the characteristics of films for optoelectronic application. The surface roughness and the depth of films were 23.6 nm and 70.21 nm, respectively. On the other hand, copper nitrate hexahydrate, cadmium nitrate tetrahydrate, tin chloride dihydrate, thiourea, 2-methoxyethanol, and 1,2-dichlorobenzene were used to deposit $\text{Cu}_2\text{CdSnS}_4$ (CCTS) films onto ITO glass substrate [65]. Spin-coated CCTS films show a weak diffraction peak, have an average grain diameter of 8.52 nm and exhibit a strong peak corresponding to (112) plane. HRTEM image confirmed the nanocrystalline nature of films and tetragonal structure. They notice that the power conversion efficiency of CCTS films (having thickness of 90 nm) is higher (3.63 %) if compared to other samples (2.41-3.51 %). Because of compactness and uniform surface, it produced optimum interface and improved the charge transfer dynamics.

The Cu_2SnS_3 (CTS) films were deposited on glass substrate using the spin coating [66]. Copper (II) acetate monohydrate, tin (II) chloride, thiourea, 2-methoxyethanol, Triton-X-100 (resulted in smoother and continuous texture), and diethanolamine were used during the deposition process. Tetragonal structure with the major peak corresponded to (112) plane based on XRD data. Crystallite size increased (17 to 23 nm) whereas microstrain (2.2×10^{-3} to 1.6×10^{-3}), dislocation density (2.6×10^{15} to $1.8 \times 10^{15} \text{ m}^{-2}$) reduced with increasing Triton-X-100 content (1 to 3%). Morphology study was performed using the atomic force microscopy (AFM) tool. Spin-coated films were rough compact without holes, indicating they are suitable to avoid shunting problems in solar cells [67]. A bigger grain size could be observed, reducing recombination at grain boundaries and involving carrier transport within the grain. Ideal band gap values (1.19 to 1.65 eV) and the observed light sensibility cause these materials to be a promising candidate for solar cell application. Raman spectra were used to analyze the composition of films. Two peaks (289 and 352 cm^{-1}) were detected, representing the vibration symmetry of CTS films. XPS was used to study the film's chemistry nature. The obtained results show Cu $2p^{1/2}$, $2p^{3/2}$, Sn $3d^{3/2}$, $3d^{5/2}$, S $2p^{1/2}$ and S $2p^{3/2}$. Hall effect measurement was carried out, and results show p-type semiconductor material (Hall coefficient= $1.3 \text{ cm}^3/\text{C}$). Lastly, the CTS was used as the absorber material to check photovoltaic device performance [68]. It reached a solar conversion efficiency of 0.78% with a fill factor (27.4 %).

Acetic acid, ethanol, polyethylene glycol, thiourea, and cadmium nitrate were employed to grow CdS films onto glass substrate at various annealed temperatures [69]. XRD studies found that more diffraction peaks (four peaks) and better polycrystalline could be detected at 2200 rpm, 400 °C. The direct bandgap (3.03, 2.88, and 2.75 eV) reduces with increasing temperature from 200 to 400 °C, indicating a quantum confinement effect. High-resolution transmission electron microscopy results indicate lattice fringes representing the formation of good nanocrystalline in the annealed films (150 °C). Further, they conclude that d-spacing of 0.357 nm corresponded to (100) reflection of hexagonal structure and grain size of 5 nm. Atomic force microscopy images show small grains, homogeneous, without voids, and the roughness of 37 nm [70]. The photoluminescence (PL) emission spectra exhibit two peaks at 486 (green emission) and 542 nm (yellow band). The influence of spin coating speed on the properties of CdS was studied. The observed sharp peak at 5000 rpm, shows the presence of good crystalline and is suitable for photocatalytic reaction. The grain size increases with an increase in spin coating speed based on the calculation of the Scherrer formula (from 1.4 to 6.3 nm) and SEM images [71]. The studies of transmittance spectra show 40-50 % and 80 % transmission at 1000 and 5000 rpm, respectively.

In the past few years, there have been several reports on the properties of thin films prepared using the spin coating method, as shown in Table 4. Investigation into the material properties by using various tools was performed. The main disadvantage of this technique is its lack of material efficiency. The actual material used is about ten percentages, the rest being flung off the side. The fast drying times can also cause lower performance for some particular nanotechnology.

Table 4: Thin films prepared using spin coating technique.

Thin films	Experimental conditions	Highlighted results
Copper doped ZnS	<ul style="list-style-type: none"> Synthesis of copper doped ZnS films on filter paper (as flexible substrate) in the presence of zinc chloride and thiourea. 	<ul style="list-style-type: none"> SEM studies: indicate fibrous morphology [72]. XRD studies: cubic structure The obtained films show excellent photoluminescence properties and conductivity value (3.07 to $4.3 \times 10^6 \Omega^{-1}\text{cm}^{-1}$).
ZnS	<ul style="list-style-type: none"> ZnS films were prepared on a glass substrate. Zinc sulfate and polymethylmethacrylate were used during the deposition process. 	<ul style="list-style-type: none"> SEM studies: Semispherical morphology [73]. XRD studies: the most preferential peak corresponded to (111) plane, and crystallite size was 35 nm. Optical properties: bandgap was 4.12 eV, and absorbance in the ultraviolet region is high.
ZnS	<ul style="list-style-type: none"> Preparation of zinc sulphide films by adding dimethylsulphoxide. 	<ul style="list-style-type: none"> XRD studies: hexagonal structure and polycrystalline in nature [74]. EDAX studies: nearly stoichiometric films. SEM studies: smooth and uniform grains (20-25 nm). Optical properties: high transmittance in the visible region, and bandgap was 3.6 eV.
ZnS	<ul style="list-style-type: none"> ZnS films were grown on quartz substrate, and the raw materials were zinc nitrate and thiourea. 	<ul style="list-style-type: none"> XRD studies: hexagonal wurtzite structure and the major peak was (100) plane [75]. SEM studies: formation of sub-micrometer grains on the surface. Optical properties: bandgap was 3.7 eV.

CdS	<ul style="list-style-type: none"> Cupric acetate, thiourea and cadmium acetate as starting materials. Copper ions were added to CdS films at various spin speeds and times. 	<ul style="list-style-type: none"> XRD studies: addition of a small amount of copper ions did not change the structure [76]. Optical properties: Bandgap reduces (2.45 to 2.18 eV) with the percentage of copper ions from 0.1 to 0.6 %. Photovoltaic properties: Fill factor (19.69 to 49.21 %), efficiency (0.09 to 0.86 %) and photocurrent density (0.013 to 0.046 mA.cm⁻²) increase with the percentage of copper ions from 0.1 to 0.6 %.
CuInSe ₂	<ul style="list-style-type: none"> CuInSe₂ films were grown on a quartz substrate. 	<ul style="list-style-type: none"> EDAX studies: the films prepared nitrogen atmosphere show a deficiency of selenium. The ratio of Se: (Cu+In)=0.55. XRD studies: improvement of crystallinity under appropriate sintering time and the sintering selenium vapour [77].
SnS ₂	<ul style="list-style-type: none"> The growth of SnS₂ films at room temperature. 	<ul style="list-style-type: none"> XRD studies: hexagonal structure and the crystallite size was obtained (9.7, 6.5 nm). EDAX studies: near stoichiometric films [78]. SEM studies: flat, uniform morphology and free cracking. Optical properties: band gap increases with reduce in film thickness
PbS	<ul style="list-style-type: none"> PbS films were prepared on glass substrate. 	<ul style="list-style-type: none"> XRD studies: good crystalline cubic structure [79]. SEM studies: homogeneous surface. Optical properties: Direct band gap was 0.41 eV and high absorption coefficient (10⁴cm⁻¹).
Cu ₂ SnS ₃	<ul style="list-style-type: none"> Synthesis of Cu₂SnS₃ by using polyethylene glycol (PEG). 	<ul style="list-style-type: none"> XRD studies: polycrystalline in nature [80]. SEM studies: dense, agglomeration like morphology. Optical properties: Band gap increased with decreasing the PEG content.
Cu ₂ ZnSnS ₄	<ul style="list-style-type: none"> Cu₂ZnSnS₄ films were produced by using copper (II) chloride, zinc (II) chloride, tin (IV) chloride, thiourea. 	<ul style="list-style-type: none"> XRD studies: The preferential peaks were (112), (220) and (312) planes [81]. SEM studies: uniform surface. Optical properties: band gap of 1.5 eV. Electrical properties: <i>p</i>-type conductivity, resistivity (0.014 Ω-cm), mobility (5.4 cm²V⁻¹s⁻¹) at room temperature.

Cu ₂ ZnSnS ₄	<ul style="list-style-type: none"> Cu₂ZnSnS₄ films were annealed in air under various temperatures (300 to 350 °C). 	<ul style="list-style-type: none"> XRD studies: formation of kesterite phase [82]. Optical properties: Small band gap values (1.5 to 1.63 eV). Electrical properties: electrical resistivity values (0.1 to 0.15 Ω.cm).
CdS	<ul style="list-style-type: none"> The growth of CdS films on glass substrate from solution of cadmium acetate, 2-methoxyethanol and polyethylene glycol. 	<ul style="list-style-type: none"> XRD studies: hexagonal structure with (002) orientation and the crystallite sizes (5.5 to 6.8 nm). SEM studies: bigger grain and densely packed grains [83]. Optical properties: Band gap values (2.18 to 2.4 eV).
FeS ₂	<ul style="list-style-type: none"> FeS₂ films were prepared on glass substrate followed by annealing in a sulphur conditions under various temperatures. 	<ul style="list-style-type: none"> SEM studies: there are some cracks and voids could be detected [84]. XRD studies: crystallinity was improved with increasing of the sulfurization temperature. Optical properties: band gap was increased at lower temperature. Electrical properties: lower resistivity value and higher Hall mobility, for the films prepared in lower temperature.
CuInSe ₂	<ul style="list-style-type: none"> Cu(NO₃)₂, InCl₃ and ethyl cellulose were used as starting materials to produce CuInSe₂ films. 	<ul style="list-style-type: none"> SEM studies: uniform surface with bigger grain size [85]. EDAX studies: near stoichiometric. XRD studies: CuInSe₂ films could be produced with increasing selenization temperature.
CdS, PbS	<ul style="list-style-type: none"> PbS and CdS films were produced from methanolic metal-thiourea complex. 	<ul style="list-style-type: none"> XRD studies: pure cubic structure was observed [86]. SEM studies: smooth surface and homogeneous. Optical properties: Band gap of PbS and CdS was 1.65, and 2.5 eV, respectively. Electrical properties: p-type with electrical conductivity (0.8 S/cm) in PbS films.
CuInS ₂	<ul style="list-style-type: none"> Copper acetate monohydrate and indium acetate were used to synthesis CuInS₂ films on glass substrate. 	<ul style="list-style-type: none"> SEM studies: Surface roughness was 19.1 nm [87]. XRD studies: chalcopyrite structure was found. Raman spectra: Pure phase without a secondary structure such as InS and CuS.
CuSe	<ul style="list-style-type: none"> CuSe films were deposited on glass substrate. 	<ul style="list-style-type: none"> XRD studies: polycrystalline in nature [88]. SEM studies: uniform surface without pores. EDAX studies: the presence of copper and selenide in films.

		<ul style="list-style-type: none"> Optical properties: bandgap was 2.9 eV.
CuInSe ₂	<ul style="list-style-type: none"> CuInSe₂ films were produced via two-step spin coating (raw materials such as copper and indium naphthenates). 	<ul style="list-style-type: none"> Photoluminescence studies: two peaks could be detected (0.85 and 1.05 eV) [89].

2. CONCLUSION

In this work, preparation and characterization of various types of thin films by using the spin coating method were reported. The physical characteristics were studied through X-ray diffraction, scanning electron microscopy, atomic force microscopy, energy-dispersive X-ray spectroscopy, and UV-visible spectrophotometer technique. Bandgap energy could be determined from the absorption measurement. XRD patterns confirmed that the average grain size is in the nanometer scale. The obtained films could be used for photovoltaic applications due to the appropriate bandgap value.

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